

Tailoring wettability and photocatalytic properties of NiO nanosystems fabricated by plasma-assisted vapor deposition

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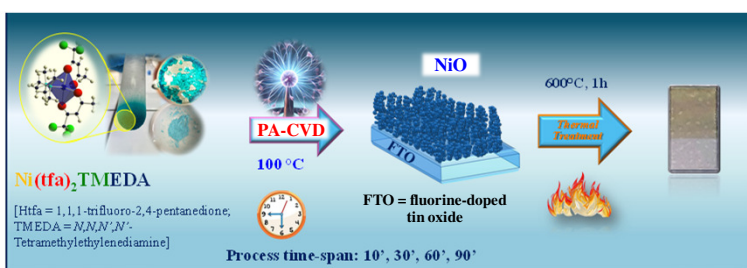


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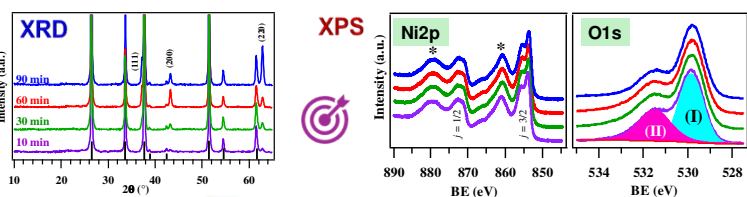
INTRODUCTION & AIM

- NiO supported nanostructures are fabricated via an original plasma assisted-chemical vapor deposition (PA-CVD) on glassy substrates at temperatures of 100°C, the lowest ever reported for similar processes, starting from a second-generation precursor, Ni(tfa)₂TMEDA [1-3].
- Variations of the sole process duration from 10 to 90 minutes allow to modulate the system morphology, and, in particular, grain dimensions and deposit thickness. The control of the latter enables to tailor functional performances in terms of wettability and photocatalytic degradation of aqueous diclofenac (DCF = 2-[2-(6-dichloroanilino)phenyl]acetic acid), a recalcitrant pharmaceutical pollutant.

METHOD

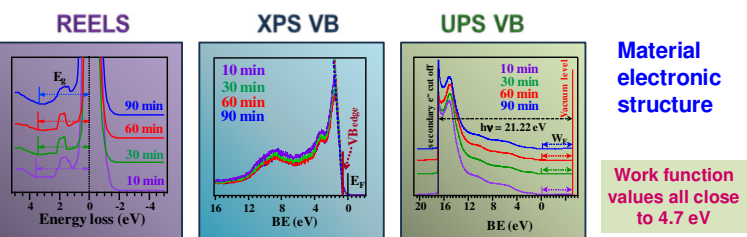


RESULTS & DISCUSSION



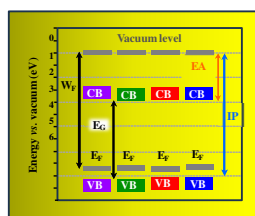
XRD patterns showed:
• Three signals from (111), (200), and (220) planes of cubic NiO
• Preferential orientations along [111] and [220] directions

- Ni2p peaks consistent with NiO (* = satellites)
- O1s bands ⇒ lattice O (I) and -OH groups adsorbed onto O defects
- Sn signal from FTO, decreases with longer deposition times
- Surface CF_x groups

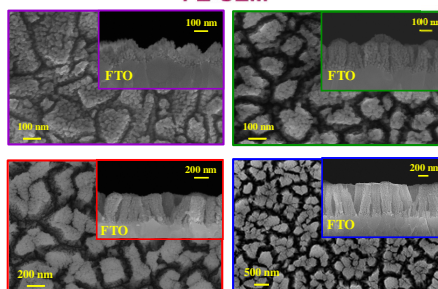


REELS spectra: intense peak at zero energy loss due to elastically scattered electrons + signal below 2 eV due to scattering collisions with H atoms, whose content ↑ at lower deposition times. ↑ PA-CVD process duration ⇒ modest E_g decrease of the measured energy gap from 3.6 to 3.3 eV

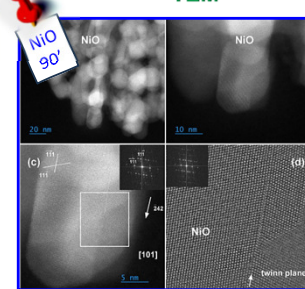
- Separation between VB edge and Fermi level: slight decrease as a function of the the PA-CVD process duration



FE-SEM

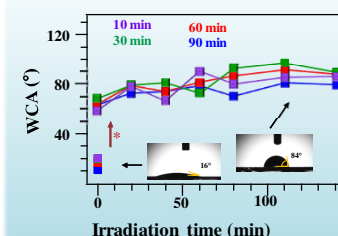


TEM



- Nanocolumnar open-area morphology promoted by a hybrid 2D-3D growth mode;
- Deposit thickness linearly increases with deposition time
- Growth control by the sole variation of process duration

Defect structure, elongated NPs of twinned single NiO nanoparticle along the <111> growth direction of the cubic structure

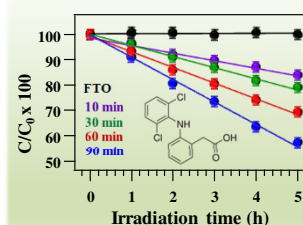


Wettability: Water contact angle (WCA) measurements

- These materials evidenced an initially higher hydrophilicity for thicker NiO systems, ascribed to a larger surface area
- WCA change over time: increase up to 60-70° after 24 days, and is further promoted upon illumination

The system hydrophobicity can be fostered by two concomitant factors:

- The presence of oxygen vacancies promote O₂ adsorption;
- The presence of surface CF_x groups helps the maintenance of the hydrophobic behavior upon irradiation.



Photodegradation of aqueous diclofenac (DCF)

- The degradation activity increases as a function of the deposit thickness
- The most hydrophilic sample produced the fastest DCF degradation
- Higher columns larger and NiO grains atop the columns favor a better UV light absorption ⇒ a more efficient charge carrier generation and a faster DCF degradation.

CONCLUSION

- Phase-pure NiO nanosystems were fabricated via PA-CVD on glassy substrates at 100°C
- Wettability and photodegradation efficiency of aqueous DCF solutions were directly affected by morphology, with particular regard to grain dimensions and deposit thickness
- The work demonstrates a straightforward strategy for preparing NiO nanostructures, applicable even to thermally labile substrates
- Surface hydrophobicity of the system can potentially be used to design catalysts with improved activity and selectivity
- Flexible control over thickness and morphology makes NiO systems promising candidates for photoactivated applications, including water splitting for green hydrogen production

REFERENCES

- [1] C. Maccato et al., Chem. Commun., 2025, 61, 2945; [2] C. Maccato et al., Surf. Sci. Spectra, 2025, 32, 024005; [3] C. Maccato et al., Dalton Trans. 2023, 52, 10677.